

PATÉNTA Customer No. 22,852 Attorney Docket No. 08038.0032

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takayuki NIUYA et al.

Serial No.: 09/658,193

Filed: September 8, 2000

For: METHOD AND APPARATUS FOR PRODUCING SEMICONDUCTOR DEVICE

Commissioner for Patents and Trademarks

Commissioner for Patents and Trademarks Washington, DC 20231

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In a restriction requirement dated September 11, 2001, the Examiner required restriction under 35 U.S.C. § 121 between Group I, claims 1-6, drawn to a method of manufacturing semiconductor devices and Group II, claims 7-10, drawn to an apparatus for manufacturing semiconductor devices.

During a telephone conference with Examiner Eaton on October 5, 2001, regarding Applicants Preliminary Amendment that was filed on July 27, 2001, the Examiner informed Applicants undersigned attorney that the Preliminary Amendment was matched with the file after the September 11, 2001, Office Action was mailed. Therefore, at this time there is no need to respond to the restriction set for in the Office Action dated September 11, 2001.

LAW OFFICES
FINNEGAN, HENDERSO

FARABOW, GARRETT & DUNNER, L.L.P. 1300 I STREET, N. W. WASHINGTON, DC 2000 202-408-4000 Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: October 5, 2001

David W. Hill Reg. No. 28,220

LAW OFFICES

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